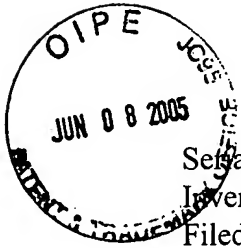


Serial Nr.: 10/699,490  
Art Unit: 2856

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: **10/699,490**

Examiner: **John E. Chapman Jr.**

Inventor: **Shyu-Mou Chen, Sheau-Shi Tzuoo and Chung-Ta Kau**

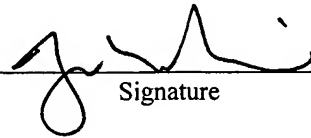
Filed: **November 1, 2003**

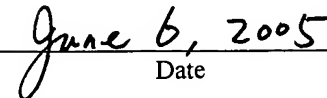
Art Unit: **2856**

Title: **Silicon Dual Inertial Sensors**

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Issue Fee, Formal Drawings, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

  
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Signature

  
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Date

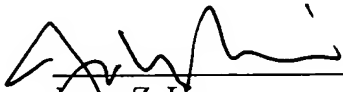
SUBMISSION OF FORMAL DRAWINGS

Honorable Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Attn.: Official Draftsperson

Sir:

Enclosed are **seven (7)** Replacement Sheets of the drawings for FIGs. **1-6** which have been approved by the Examiner for correcting informalities and filing in the above-identified U.S. patent application.

Respectfully submitted,

  
\_\_\_\_\_  
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